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July 19, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: MICRO-STAMPING METHOD FOR PHOTOELECTRIC PROCESS
Serial No.: 10/674,153
Filing Date: September 29, 2003
Our File No.: 0001035.1005

Dear Sir:


Enclosed for filing please find the following items relating to the above-identified patent application:

- (1) Transmittal Letter;
- (2) Cover Letter;
- (3) Information Disclosure Statement;
- (4) Form PTO/SB/08a;
- (5) References (1);and
- (6) Return post card.

Please file the references and return the date-stamped post card to the address indicated. Please note that we have enclosed an abstract of the cited U.S. Patent for filing. Please notify us if we need to provide a copy of the U.S. Patent as well.

If you have any questions or comments concerning this application, please call the undersigned at your earliest convenience.

Very truly yours,



Ruben C. DeLeon
Registration No. 37,812

RCD:krs
Enclosures



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Kuo-Huang HSIEH et al.	§ § § § § § § § § §	Group Art Unit: Unknown
Serial No.:	10/674,153		
Filing Date:	September 29, 2003		Examiner: Kim White
For:	MICRO-STAMPING METHOD FOR PHOTOELECTRIC PROCESS		

Information Disclosure Statement under 37 C.F.R. §§ 1.97 and 1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby submits the information listed on the attached Forms PTO/SB/08A for consideration by the Examiner.

In accordance with 37 C.F.R. § 1.97(h), the filing of this Information Disclosure Statement shall not constitute an admission that any information cited therein is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b). In the interest of full and complete disclosure to the Office, some or all of the art cited herein may not be considered by the Applicant or the Undersigned to be material under the new standards of materiality defined in 37 C.F.R. § 1.56(b), enacted March 16, 1992, but may be material under the old standard of materiality defined in 37 C.F.R. § 1.56(a), last amended on November 28, 1998, or may merely be technical background which may be of interest to the Examiner. In accordance with 37 C.F.R. § 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made.

Applicant, therefore, respectfully requests that the Examiner consider each reference pursuant to 37 C.F.R. § 1.97(c). Should any questions arise, the Examiner is invited to contact the undersigned at the address or telephone number listed below.

Respectfully submitted,

Date: July 19, 2004

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By: 

Ruben C. DeLeon
Registration No. 37,812
Attorney for Applicant

Substitute for form 1449/PTO

PTO/SB/08A (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1
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Complete if Known

Application Number	10/674.153
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Filing Date	09/29/03
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First Named Inventor	Hsieh et al.
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Art Unit	n/a
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Examiner Name	Kim White
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Attorney Docket Number	1035.1005
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[illegible][illegible]

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.